



Docket No. 0524-0139.02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

Nozawa et al.)

Serial No.: 10/821,508)

Filed: April 9, 2004)

For: Manufacturing Method And Apparatus of)
Phase Mask Shift Blank)

Examiner: Rodney Glenn McDonald)

Art Unit: 1753)

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first class mail in an
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Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

July 10 2006
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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 7/10/06
Signature Date

AMENDMENT C

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of February 10, 2006, a two month extension of time being
submitted herewith, please amend the above-identified application as follows: